

Fractional Order Model for the Thermal Behavior of Bipolar Transistors

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Outline

- Introduction, self-heating
- Measurement set-up
- The new self-heating model
- Network representation
- Results, conclusion

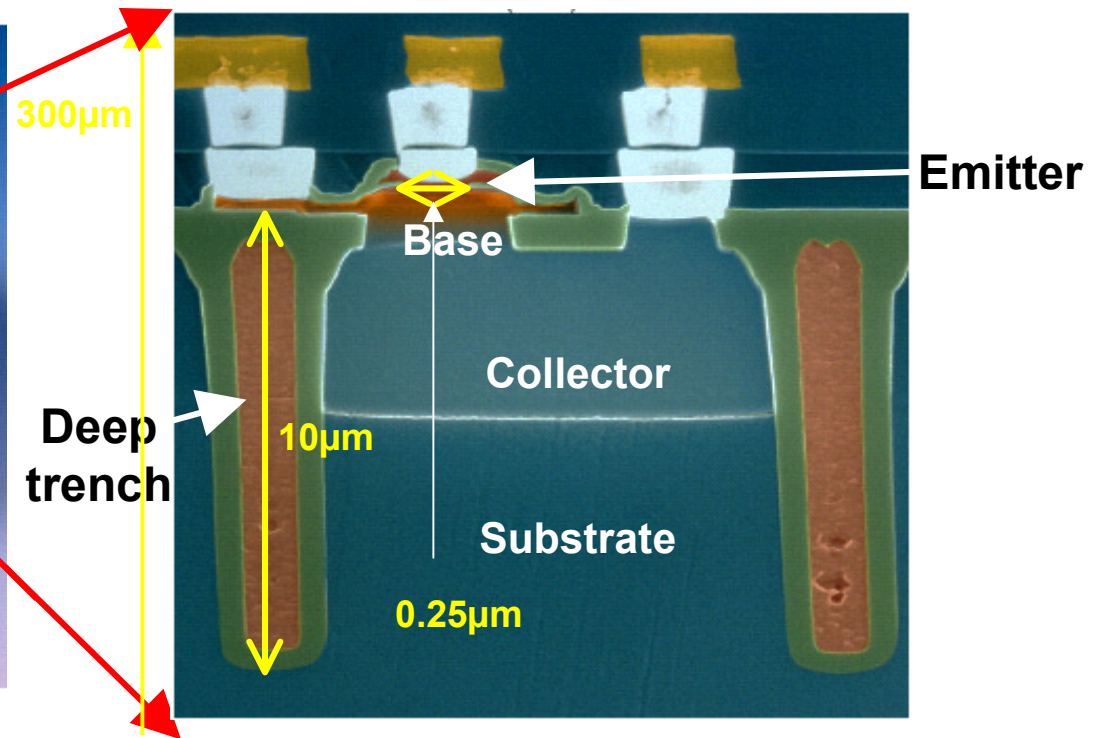
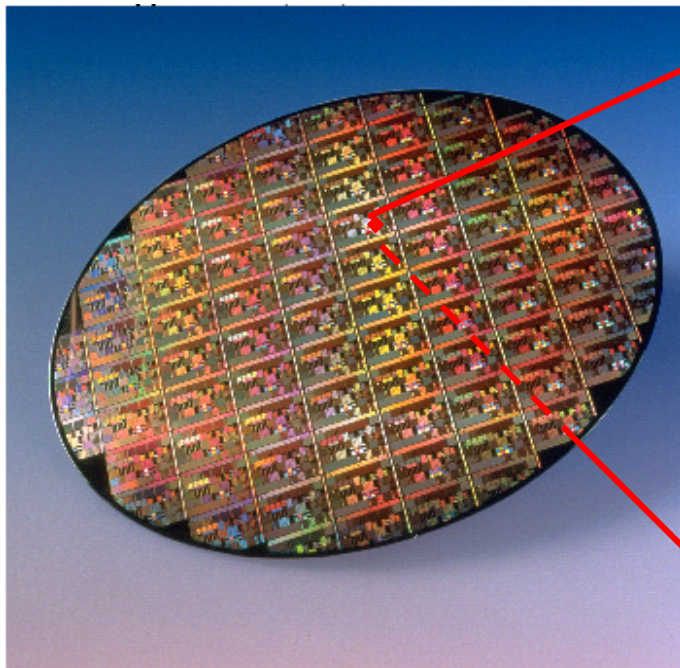
Introduction

- Self-heating:
 - Heating of the device due to its power dissipation
- Bipolar transistor:
 - First order approximation:
$$P = I_C V_{CE} + I_B V_{BE}$$
 - Effect accentuated in recent SiGe HBT technology: deep trench isolation

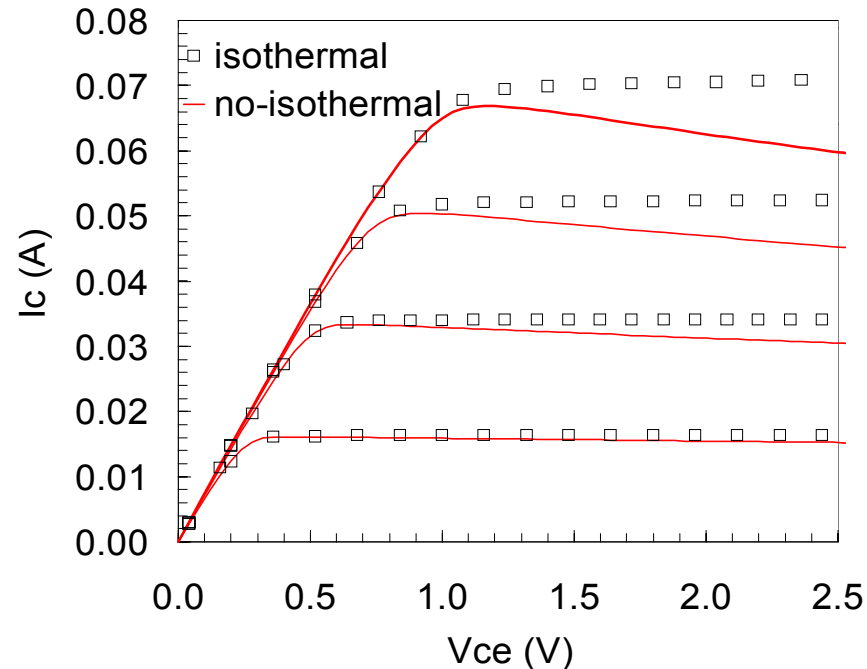
Introduction

200mm Wafer

SiGe SEM Cross-Section



Introduction



- Self-heating affects electrical characteristics
- Thermal behavior of integrated circuits can be effectively improved by means of layout optimization and technology

→ **Consistent electro-thermal model**

Electro-thermal simulation approaches

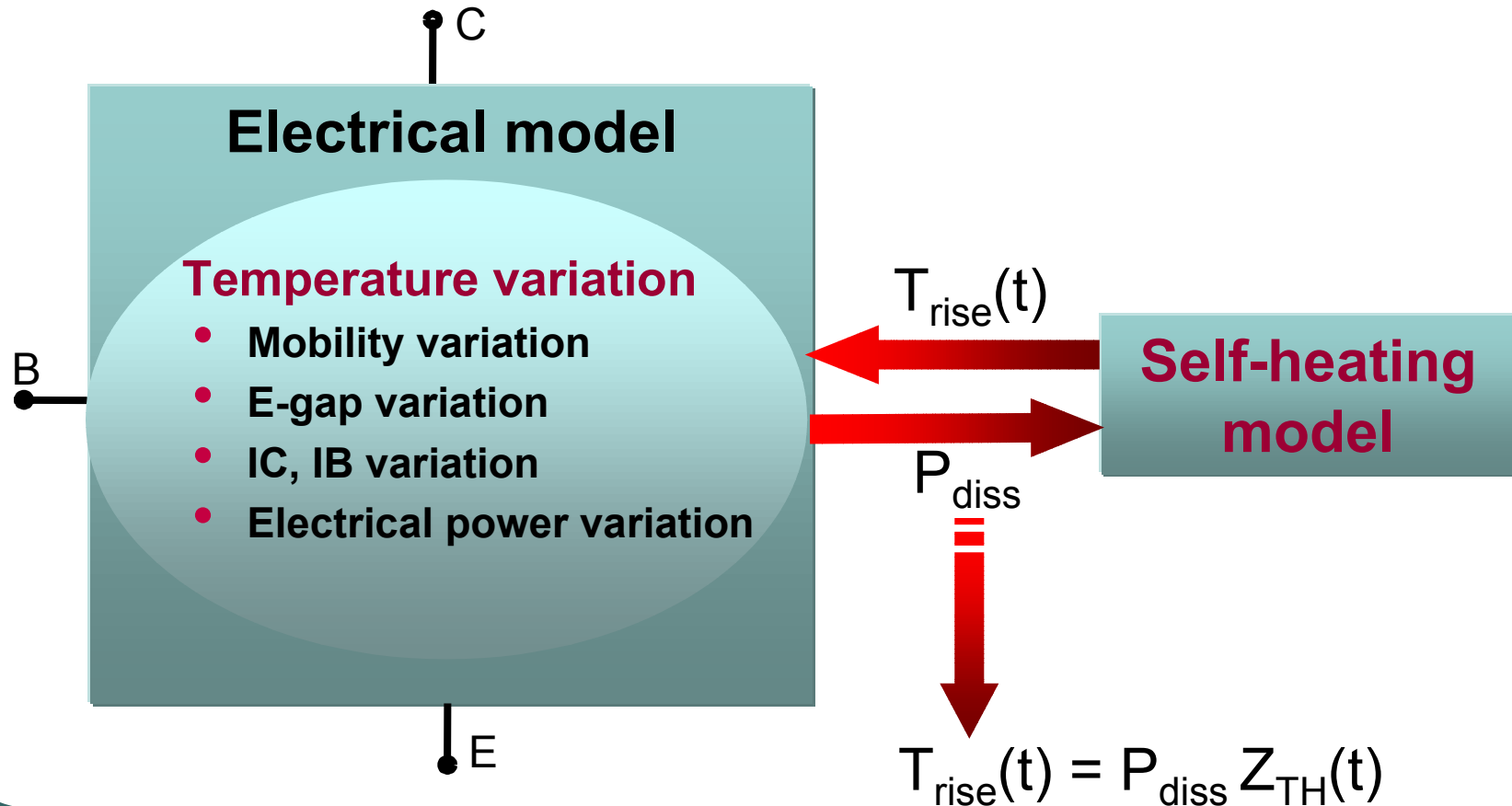
- Physical device simulation including self-heating
- Electro-thermal simulation using circuit simulation for the electrical analysis. Thermal analysis can be carried out by means of
 - Numerical method
 - Analytical method
 - **Compact thermal models**



Temperature at device nodes and heat fluxes are expressed by simple relations that can be represented by simple equivalent electrical networks

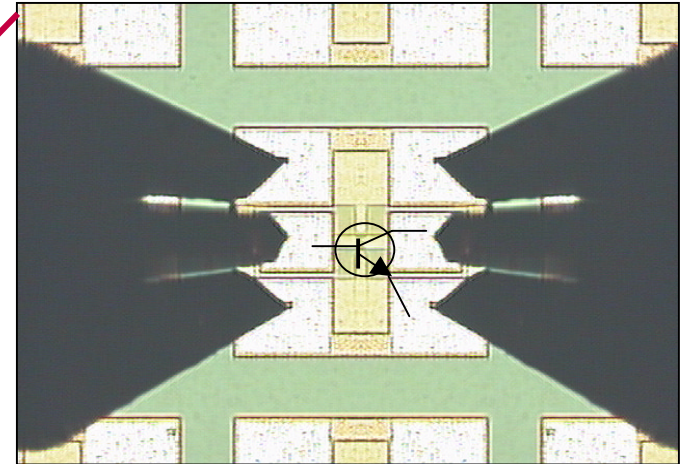
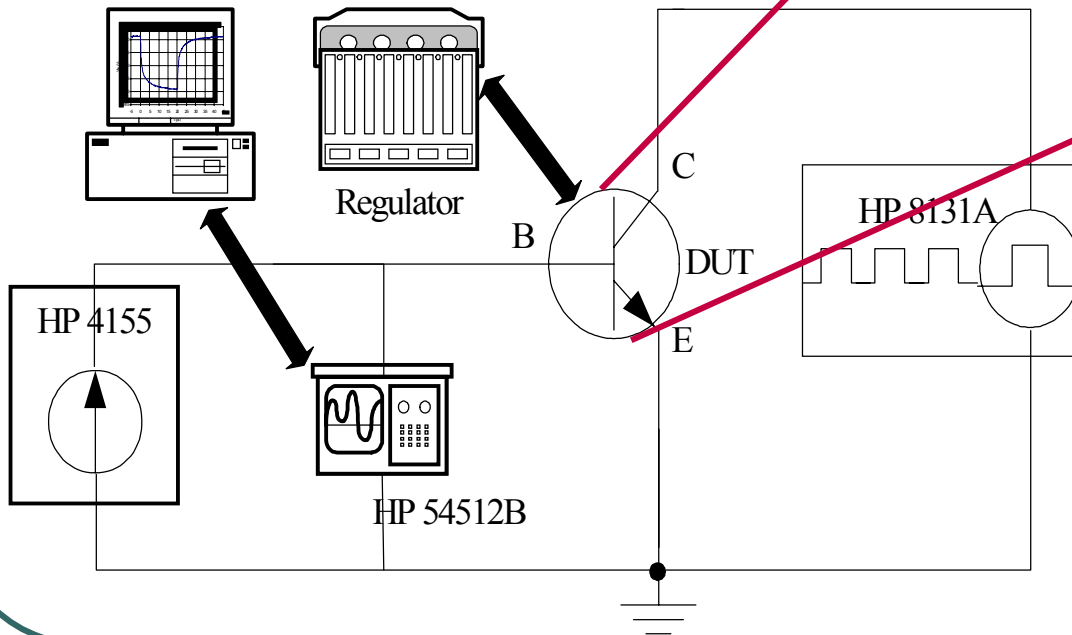
Introduction: coupling

- Electro-thermal coupling

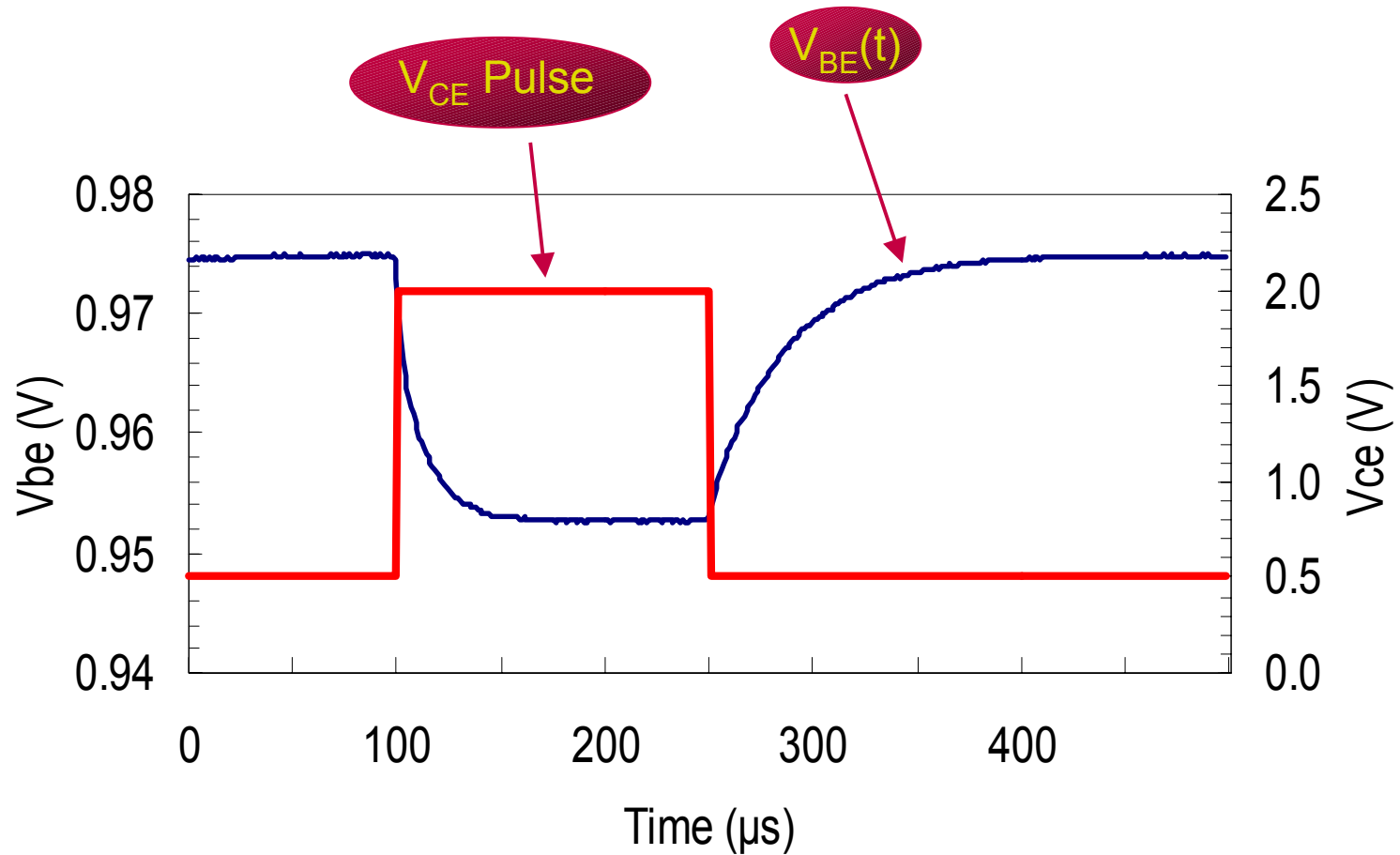


Measurement set-up: step 1

- $I_B = \text{const}$
- $V_{CE} = \text{Pulse: } V_{CE \text{ low}} \rightarrow V_{CE \text{ high}}$
- Measure of V_{BE}

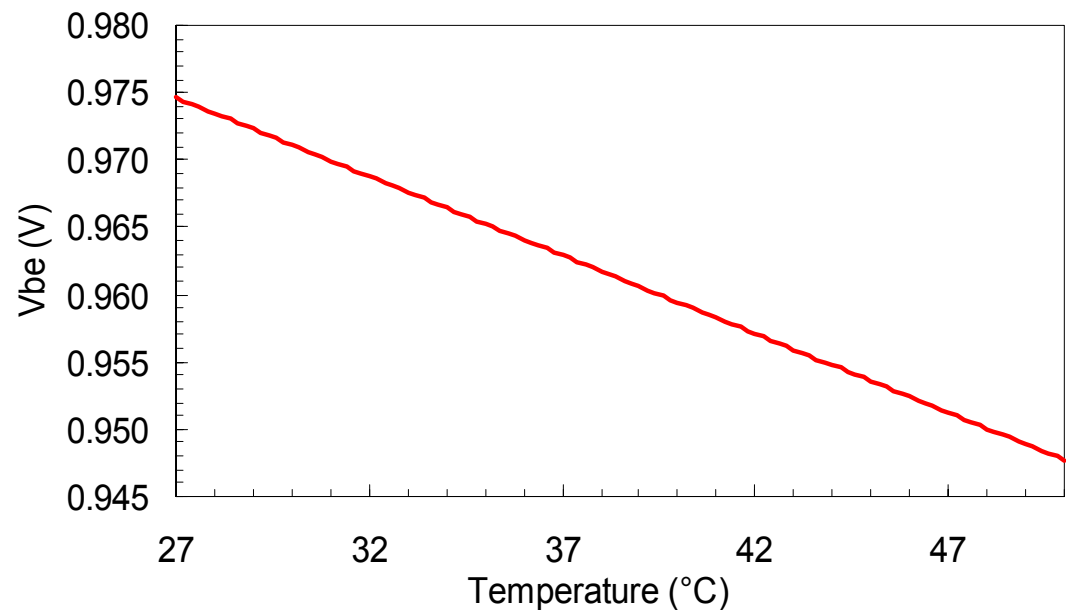


Measurement set-up: step 1



Calibration: Measure $V_{BE}(T)$, step 2

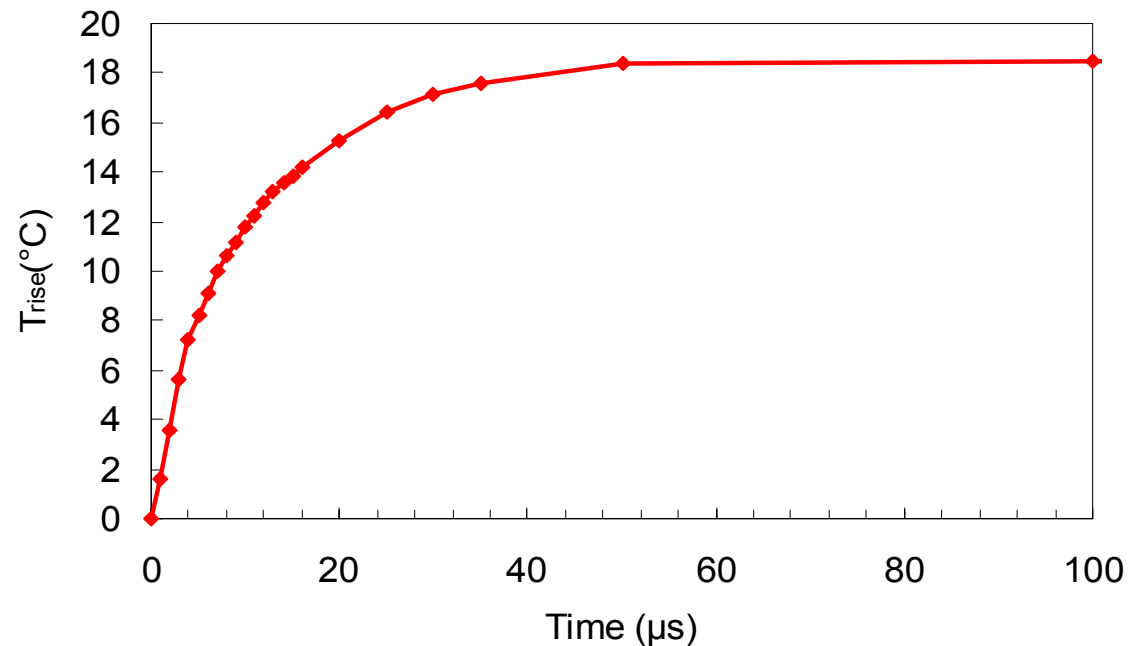
- $I_B = \text{const}$
- $V_{CE} = V_{CE\text{low}}$
- Variation of T
 - $27^\circ\text{C} \rightarrow 50^\circ\text{C}$
- Measure of V_{BE}



Dynamic behaviour: $T_{rise}(time)$, step 3

Calibration

- From $V_{BE}(t)$
- And $V_{BE}(T)$
- $\rightarrow T_{rise}(t)$

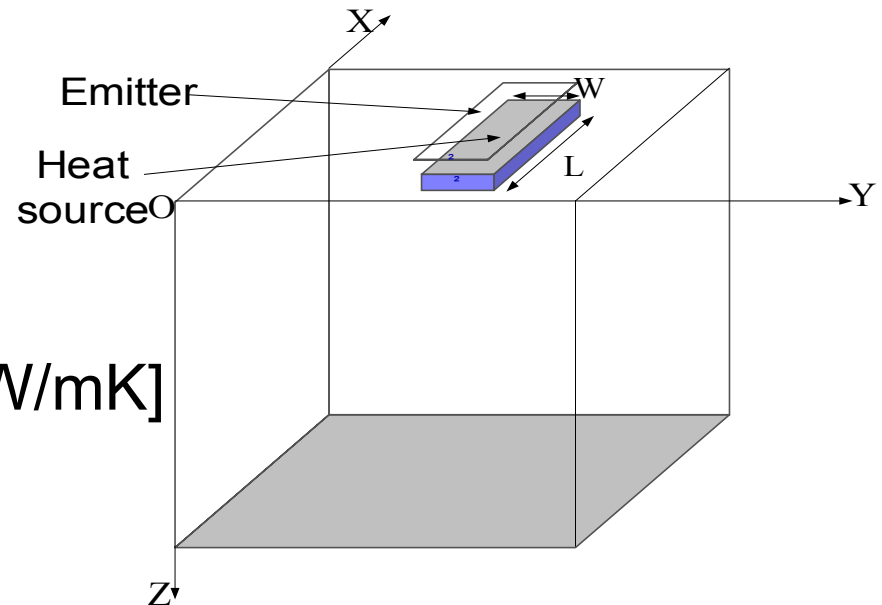


HBT SiGe: Thermal problem


- Heat transfer in semi-conductor occurs mainly through the conduction mode
 - Heat equation

$$c\rho\Delta T = \nabla(\lambda(T)\nabla T)$$

- T = temperature [$^{\circ}\text{C}$ or K]
- λ = thermal conductivity [W/mK]
- C = specific heat [J/KgK]
- ρ = density [Kg/cm^3]



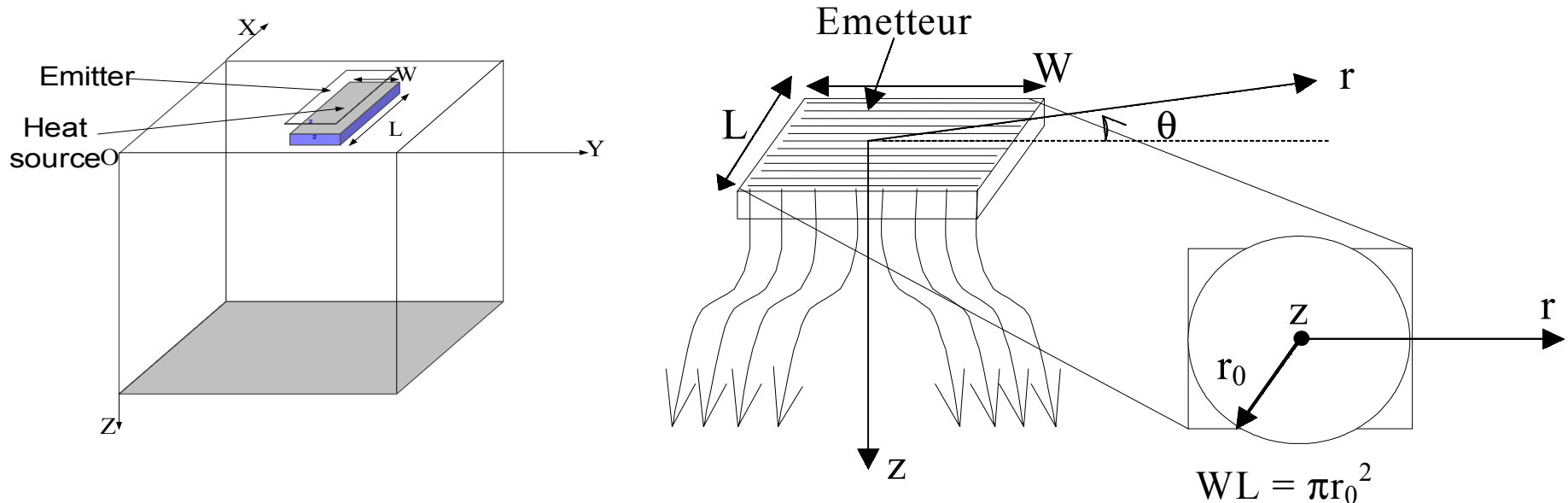
Problem complexity

- 3-dimensional heat spreading
 - 3-dimensional problem
 - Thermal conductivity is temperature dependant
 - Non linear problem
-  Approximations and simplifications

Axisymmetrical 2-dimensional Structure

- Neglected surfacing temperature gradient
 - Only vertical flux propagation is considered
- No θ -dependence
 - Symmetrical structure
- No temperature dependence of the thermal conductivity

Structure in cylindrical coordinates



$$\frac{\partial^2 T_{rise}(t, r, z)}{\partial r^2} + \frac{1}{r} \frac{\partial T_{rise}(t, r, z)}{\partial r} + \frac{\partial^2 T_{rise}(t, r, z)}{\partial z^2} = \frac{1}{a} \frac{\partial T_{rise}(t, r, z)}{\partial t}$$

$a = \lambda/c_p = \text{thermal diffusivity [m}^2/\text{s]}$

Boundary conditions (1)

- The symmetry involves directly that the temperature in the r - θ plane is maximal at $r=0$,

$$\frac{\partial T}{\partial r} = 0 \text{ for } , r = 0$$

- For the special case of an ideal heat sink, we impose Dirichlet boundary condition,

$$T = T_{\infty}, \text{ for } r \rightarrow \infty, z \rightarrow \infty$$

- A variable heat flow was applied within the active region at the top surface,

$$-\lambda \frac{\partial T}{\partial z} = q(r, t) \text{ for } z = 0, 0 < r < r_0$$

Boundary conditions (2)

- No heat flow is assumed outside the active region at the top surface,

$$-\lambda \frac{\partial T}{\partial z} = 0 \text{ for } z = 0, r > r_0$$

- Initial condition

$$\text{for } t = 0, T = T_\infty$$


Analytical problem resolution

- Calculation of the thermal impedance
 - $T_{\text{rise}}(t) = P_{\text{diss}} Z_{\text{TH}}(t)$
 - Transform into the Laplace domain and solution of differential equation:
 - $Z_{\text{TH}}(p) = \frac{R_{\text{TH}}}{\left(1 + \sqrt{R_{\text{TH}} C_{\text{TH}}} \sqrt{p}\right)}$ ← **1/2 order behavior**
- $$\begin{cases} R_{\text{TH}} = \frac{8}{3\pi^2 \lambda r_0} = \frac{8}{3\pi^2 \lambda} \sqrt{\frac{\pi}{WL}} \\ C_{\text{TH}} = \frac{8}{3} \rho c r_0^3 \end{cases}$$

Transient response

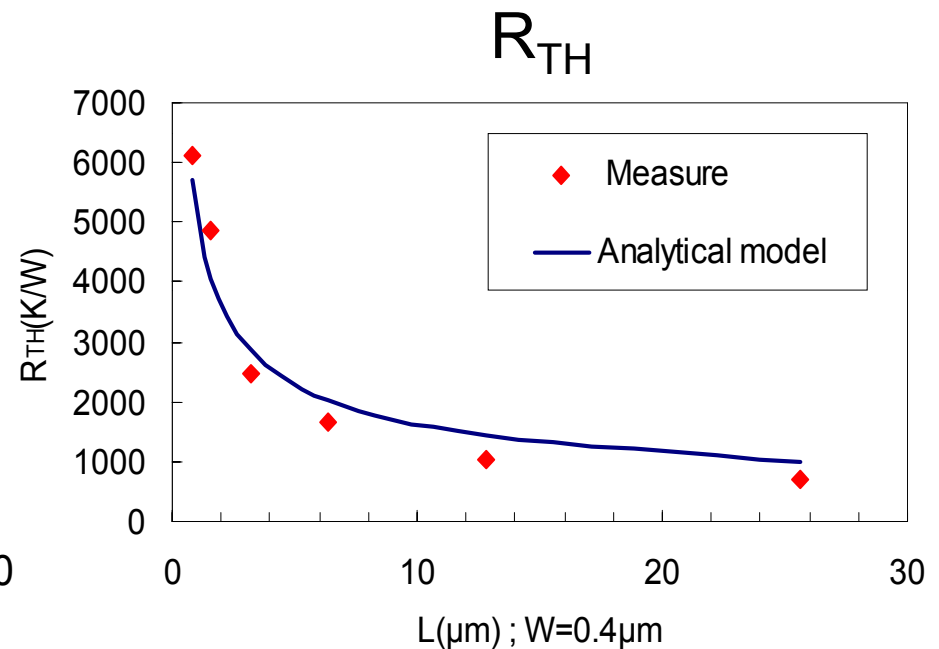
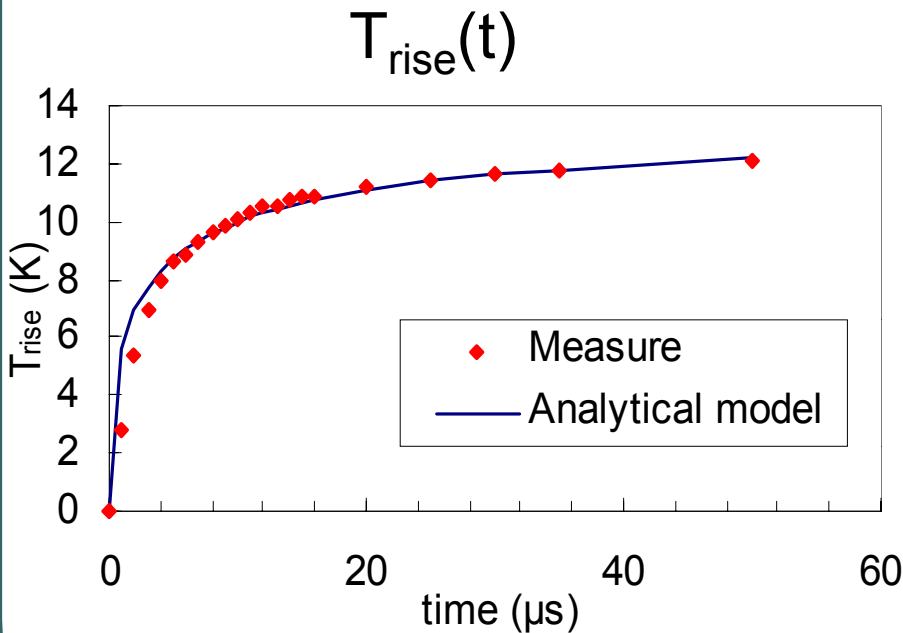
- The device temperature rise transient response is the inverse Laplace transform of $Z_{TH}(p)$:

$$T_{rise}(t) = L^{-1} \{ Z_{TH}(p) P_{diss} \}$$


$$T_{rise}(t) = R_{TH} P_{diss} \left(1 - \exp\left(\frac{t}{R_{TH} C_{TH}}\right) \operatorname{erfc}\left(\sqrt{\frac{t}{R_{TH} C_{TH}}}\right) \right)$$

Model validation

- SiGe BiCMOS technology from STMicroelectronics ($\beta = 300$ and $f_T = 160\text{GHz}$)



Electrical analogy

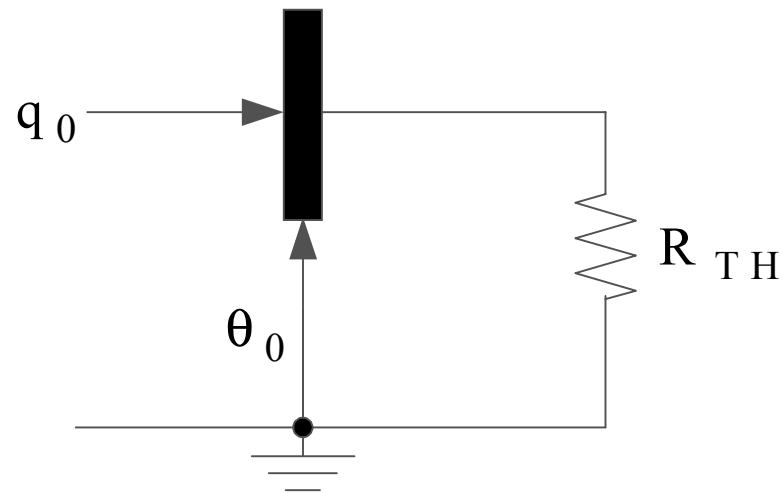
- Model inside a circuit design environment
- Network representation for SPICE compatibility

Thermal conductivity	Electrical conductivity
Temperature T (K)	Voltage V (V)
Thermal conductivity λ (W/mK)	Electrical Conductibility σ (Ωm) ⁻¹
Heat flux P (W)	Intensity I (A)
Thermal capacity C_{TH} (J/K)	Electrical capacity C (F)
Thermal resistance R_{TH} (K/W)	Electrical resistance R (Ω)

Network representation

- Thermal impedance: $Z_{TH}(p) = \frac{R_{TH}}{\left(1 + \sqrt{R_{TH} C_{TH}} \sqrt{p}\right)}$
- In the steady-state ($t \rightarrow \infty$),
that is for $p \rightarrow 0$

$$Z_{TH}(p) \rightarrow R_{TH}$$



Network representation

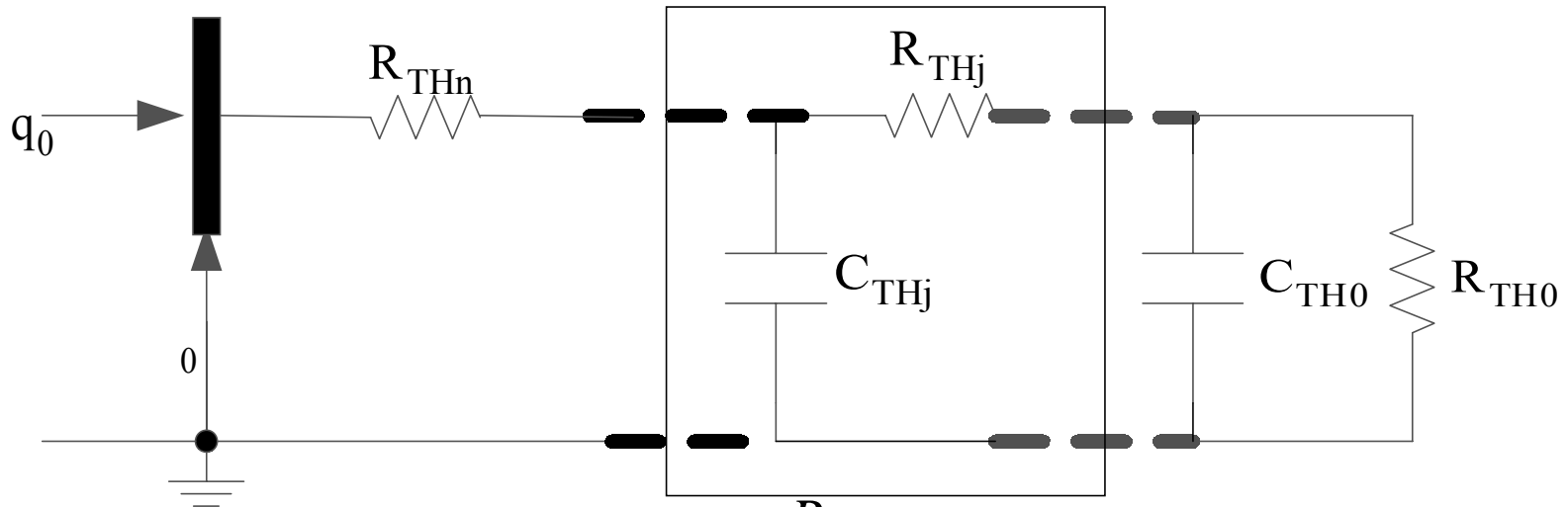
- In the transient-state ($t \rightarrow 0$), that is for $p \rightarrow \infty$

$$Z_{TH}(p) \rightarrow \sqrt{\frac{R_{TH}}{C_{TH}}} \sqrt{\frac{1}{p}}$$

- Find an equivalent network for representing the thermal impedance both, for the steady and the transient states

Linear network

- Linear network



$$R_{TH0} = R_{TH1} = R_{TH2} = \dots = R_{THn-1} = \frac{R_{TH}}{n}$$

$$R_{THn} = \frac{1}{2n} R_{TH}$$

$$C_{TH0} = C_{TH1} = C_{TH2} = \dots = C_{THn-1} = \frac{C_{TH}}{n}$$

Linear network

$$Z_{TH}(f) = R_{TH} \sqrt{\frac{1}{j \frac{f}{f_c}}} \sqrt{1 + \frac{j \frac{f}{f_c}}{4n^2}} \left(2 / \left(1 + \left[\sqrt{\frac{4n^2}{j \frac{f}{f_c}} + 1} - 1 \right] / \left[\sqrt{\frac{4n^2}{j \frac{f}{f_c}} + 1} + 1 \right] \right)^{2n+1} \right) - 1$$

$$f_c = \frac{1}{2\pi R_{TH} C_{TH}} \quad \text{cut-off frequency}$$

Linear network

- First case: $f \ll f_c$,

$$\rightarrow Z_{TH} \approx R_{TH}$$

- Corresponds to the thermal impedance in the steady state, network can be used for the steady state

Linear network

- Second case: $f \gg f_c$ and $f/f_c \ll 4n^2$

$$\rightarrow |Z_{TH}| \approx \sqrt{\frac{R_{TH}}{C_{TH}}} \frac{1}{\sqrt{f}}$$

- Corresponds to the thermal impedance in the transient state. Network represents a fractional order model for this frequency band and under the assumption that n is rather big

Linear network

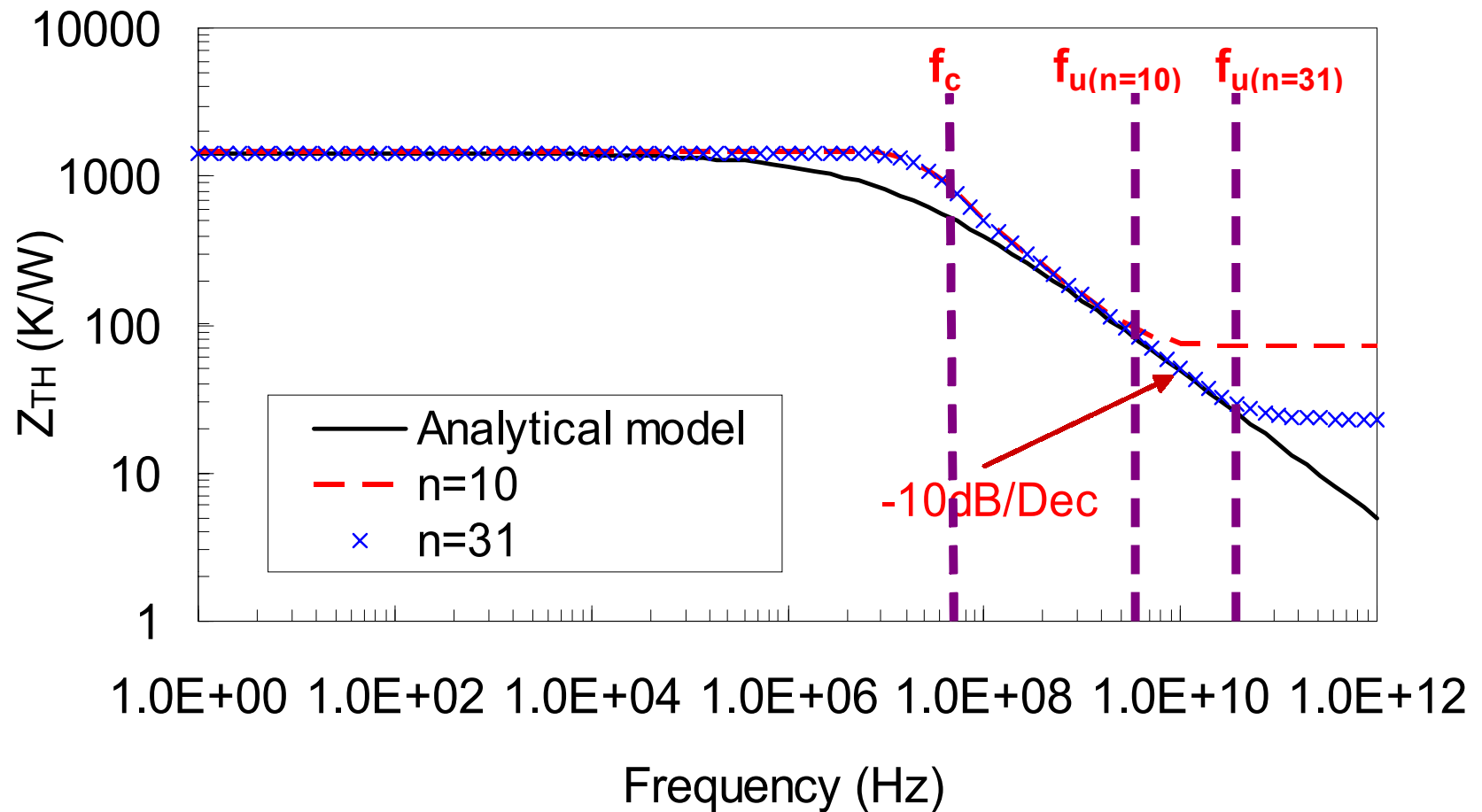
- Third case: $f \gg f_c$ and $f/f_c \gg 4n^2$,

$$\rightarrow |Z_{TH}| \cong \frac{1}{4n^2} R_{TH}$$

- Upper frequency limit f_u of network for representing the thermal impedance:

$$f_u = 4n^2 f_c$$

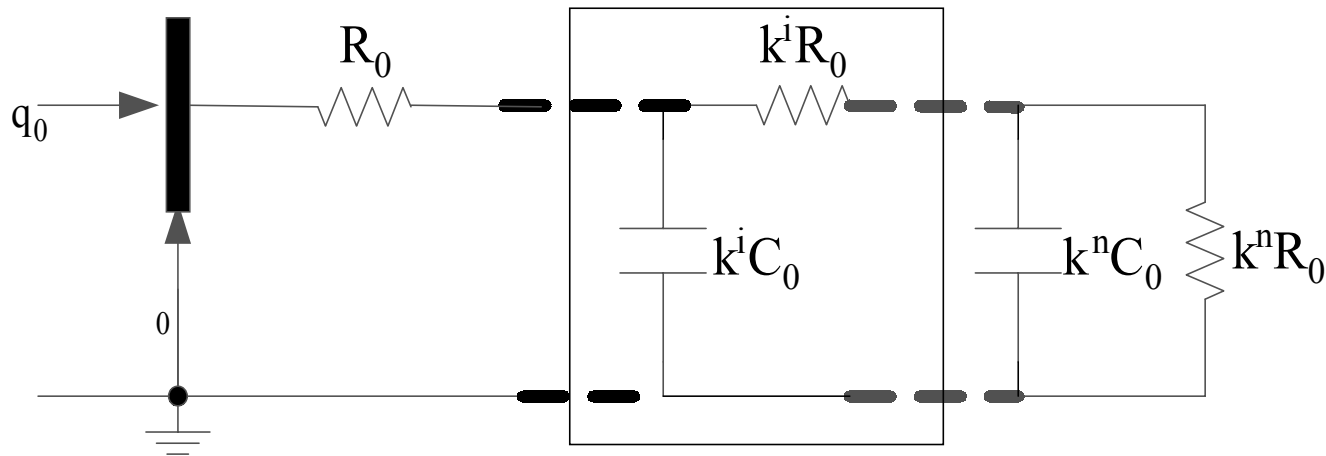
Linear network



Linear network

- $f_u = 4n^2 f_c \rightarrow \log \frac{f_u}{f_c} = 2 \log(2n)$
- Increasing the frequency fit by two decades
 - Increasing n by 1 decade
 - For an accurate representation over a large frequency range, a great number of cells is necessary
 - Drawback for usability in practical applications due to complexity and CPU simulation time

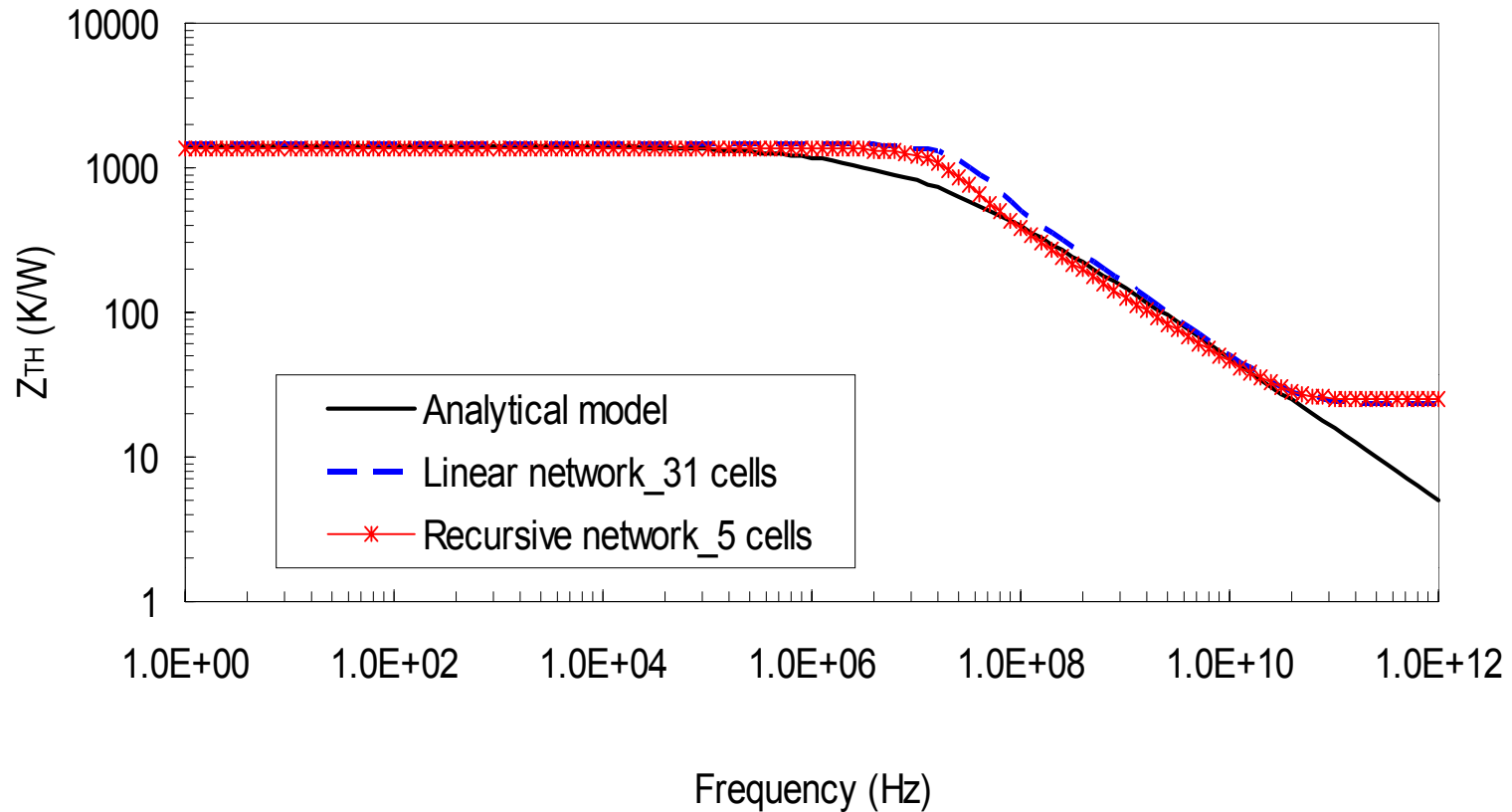
Recursive network



- k : recursivity coefficient, an additional degree liberty

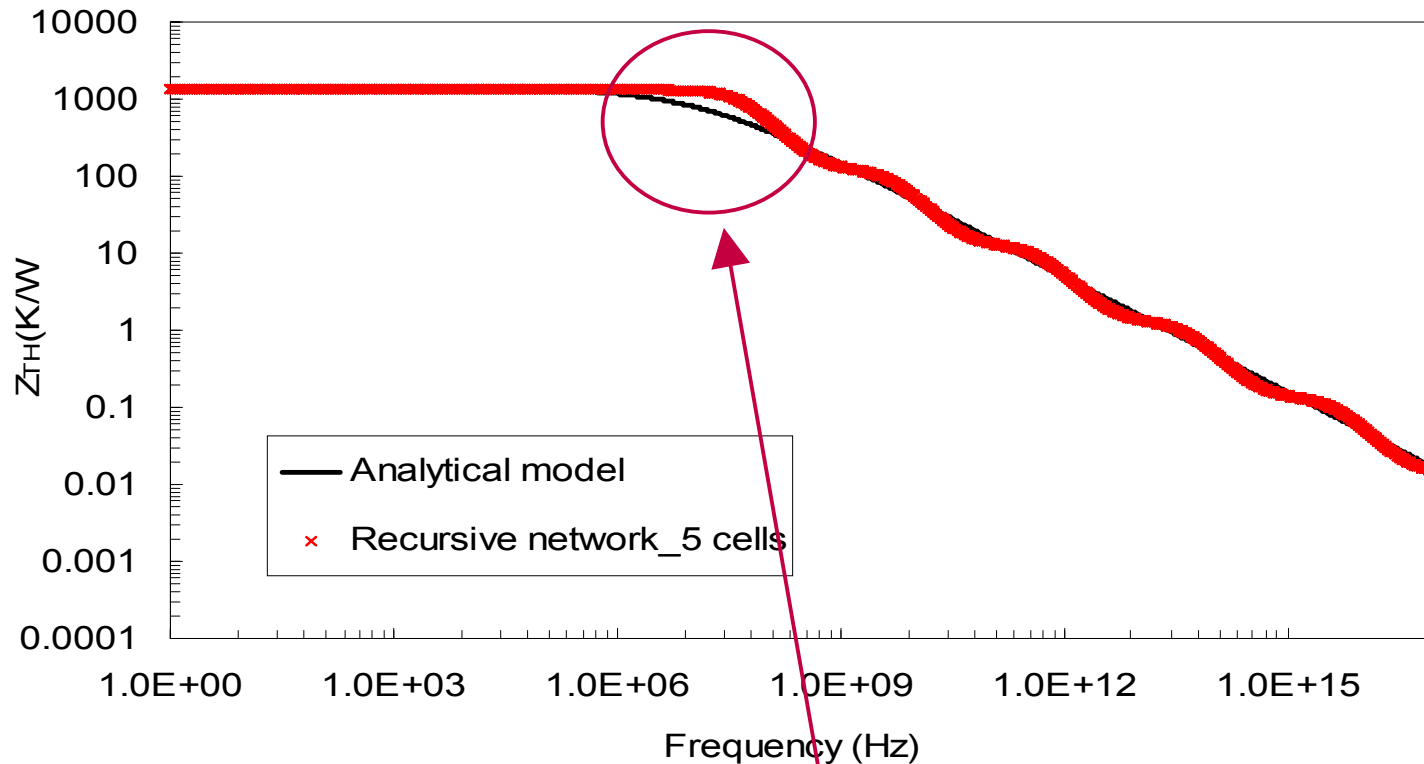
$$\rightarrow f_u \approx k^{2n} f_c$$

Comparison



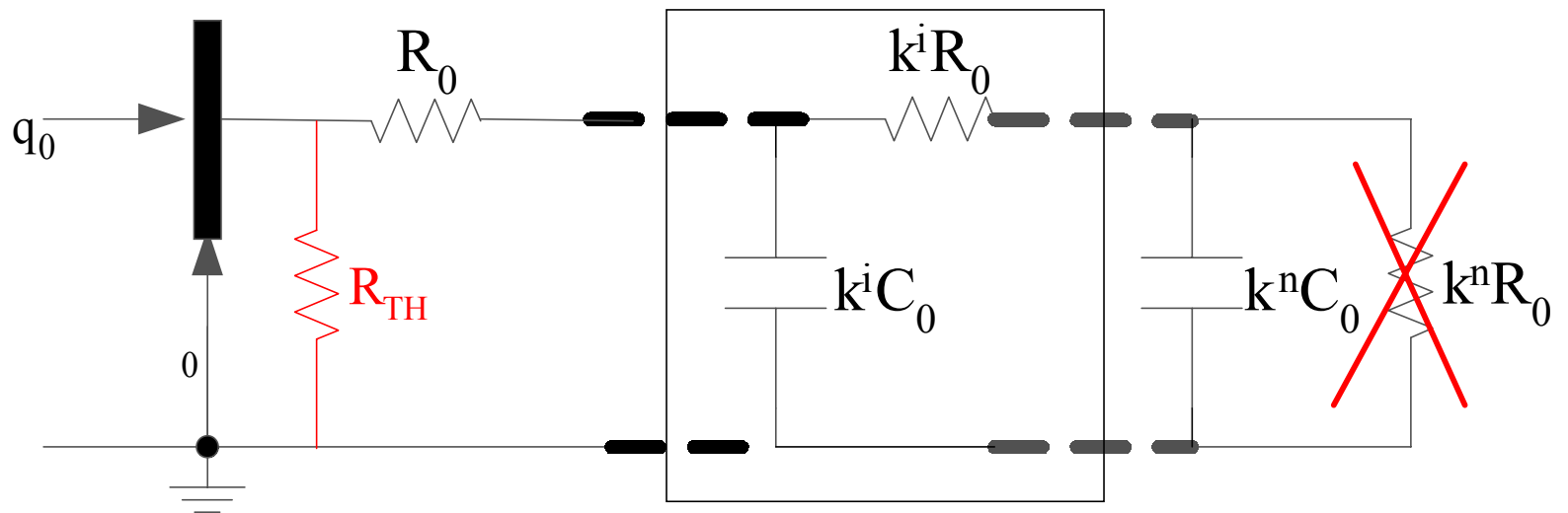
- $f_{u(n=31)}(\text{linear}) = f_{u(n=5)}(\text{recursive})$

Comparison



Imprecision near of cut-off frequency and oscillation

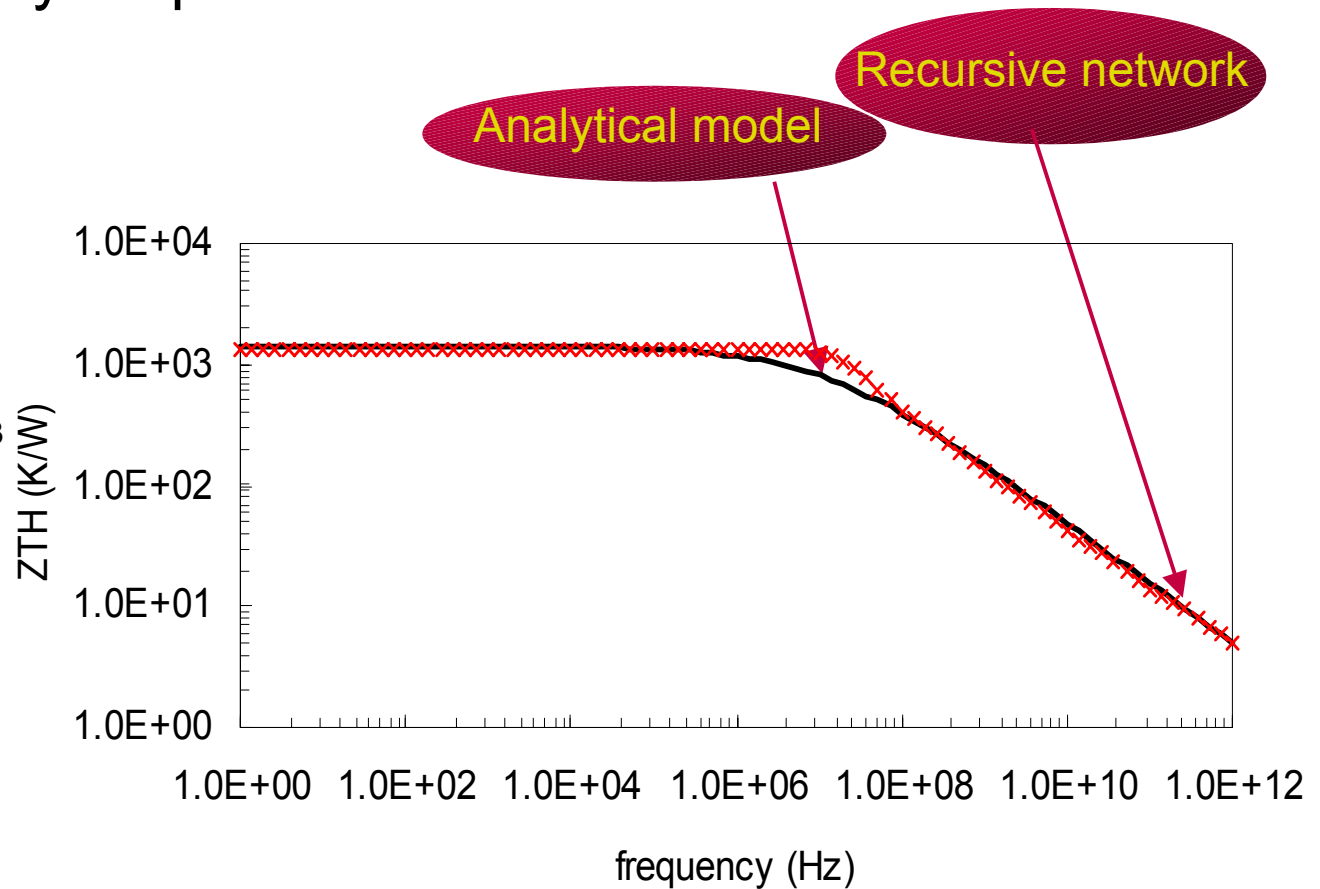
Improved recursive network



Comparison

- Frequency response: Module

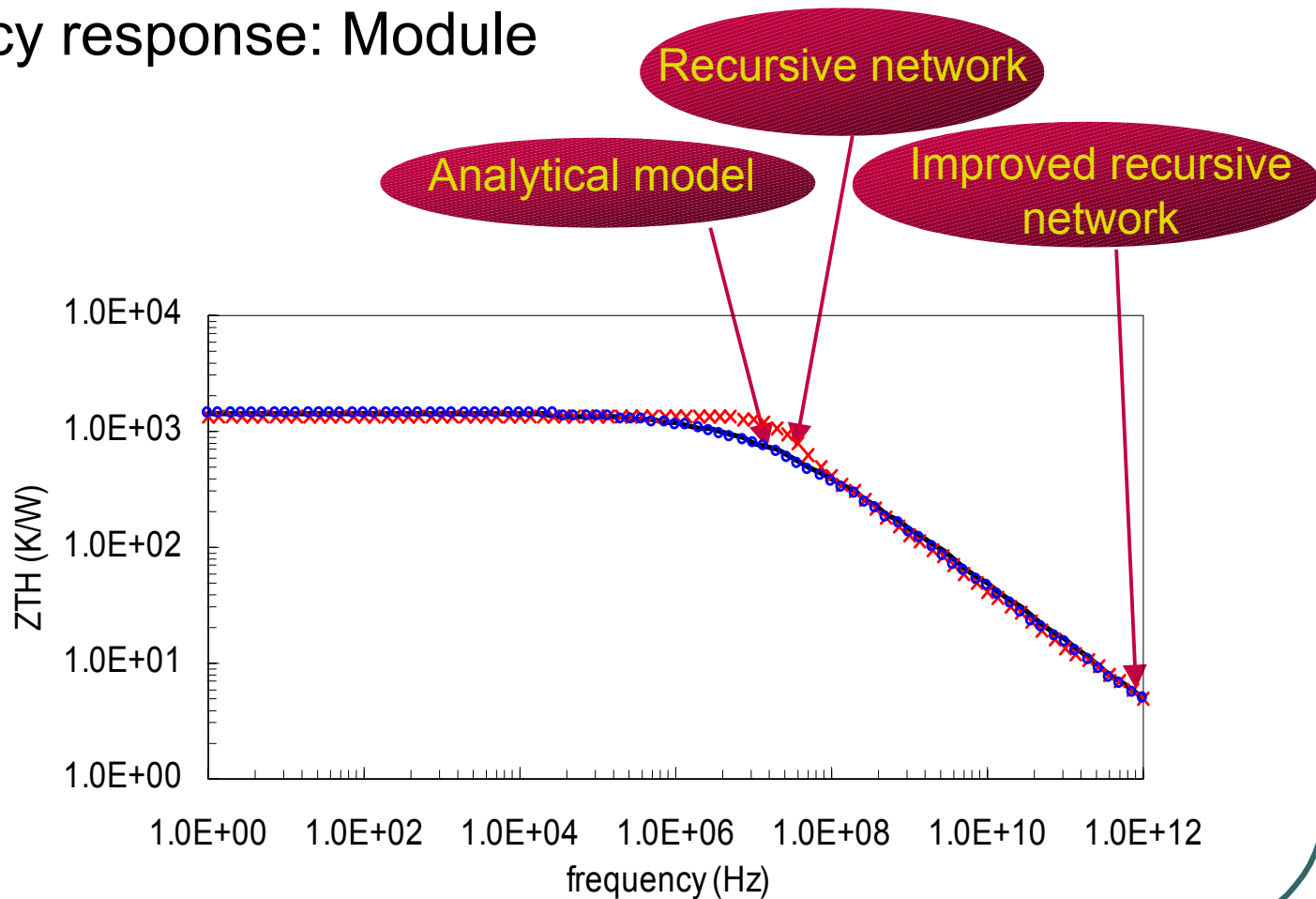
- $\lambda = 148 \text{ W/mK}$
- $C = 710 \text{ J/kgK}$
- $\rho = 2330 \text{ kg/m}^3$
- $n = 10$



Comparison

- Frequency response: Module

- $\lambda = 148 \text{ W/mK}$
- $C = 710 \text{ J/kgK}$
- $\rho = 2330 \text{ kg/m}^3$
- $n = 10$

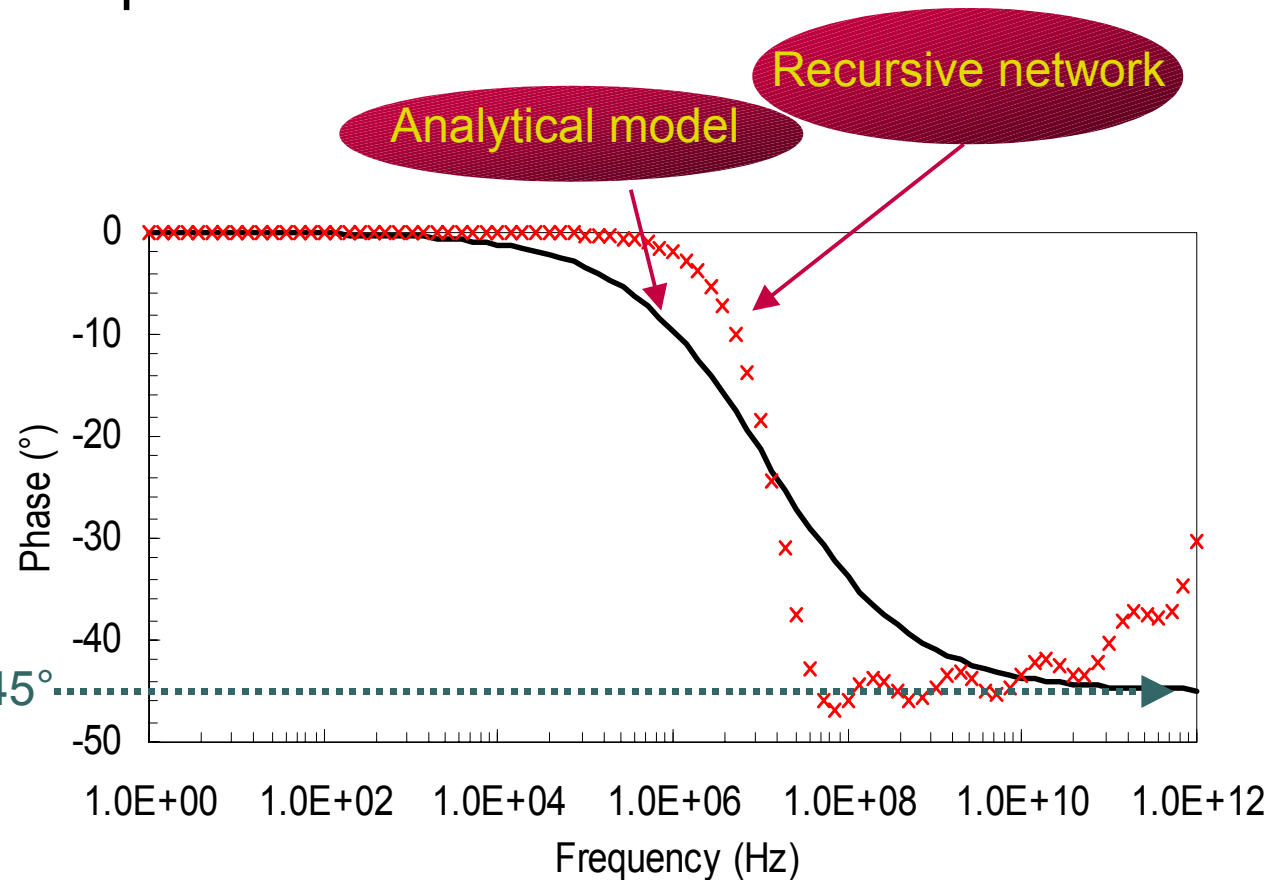


Comparison

- Frequency response: Phase

- $\lambda = 148 \text{ W/mK}$
- $C = 710 \text{ J/kgK}$
- $\rho = 2330 \text{ kg/m}^3$
- $n = 10$

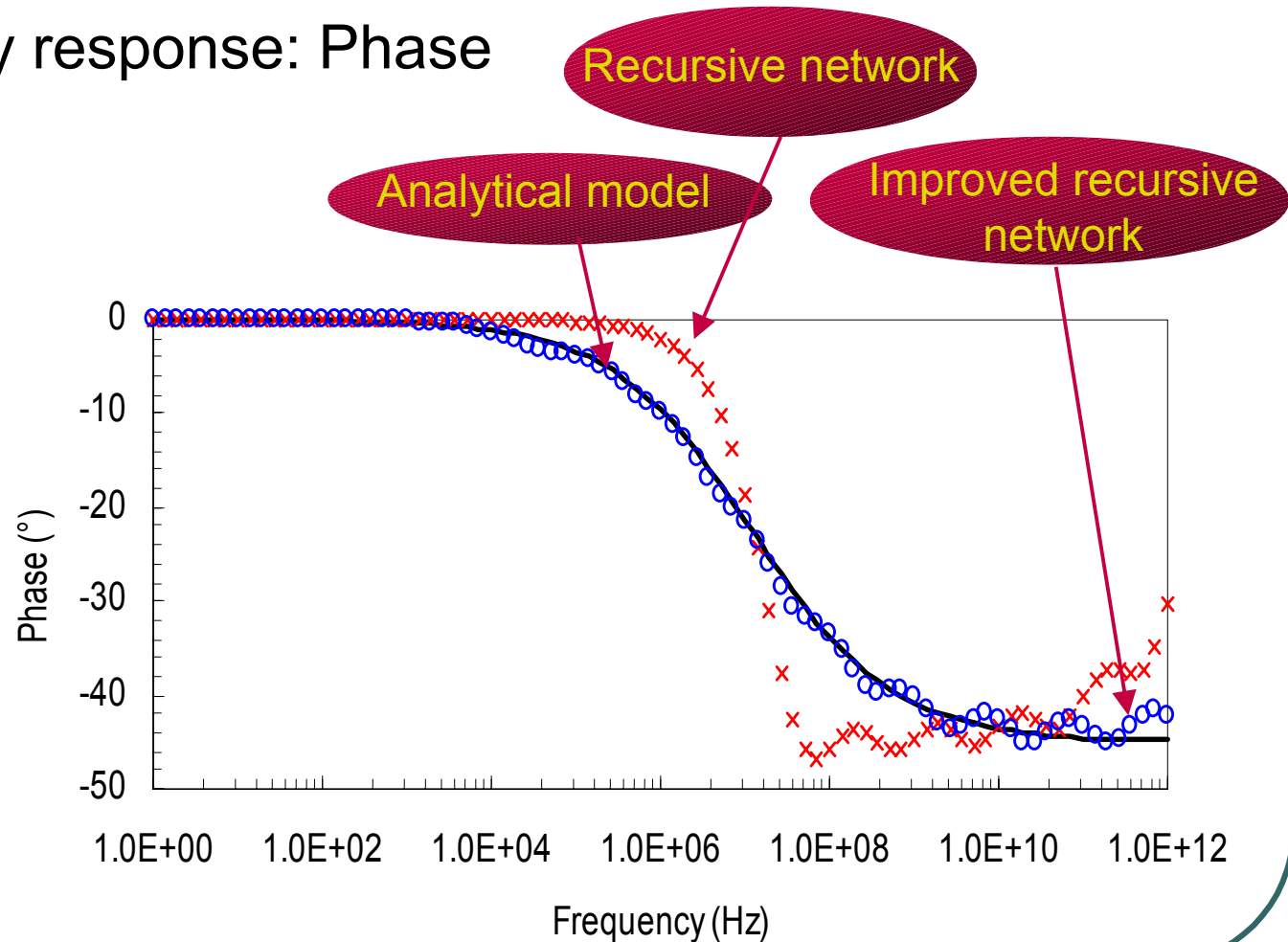
Phase difference = -45°



Comparison

- Frequency response: Phase

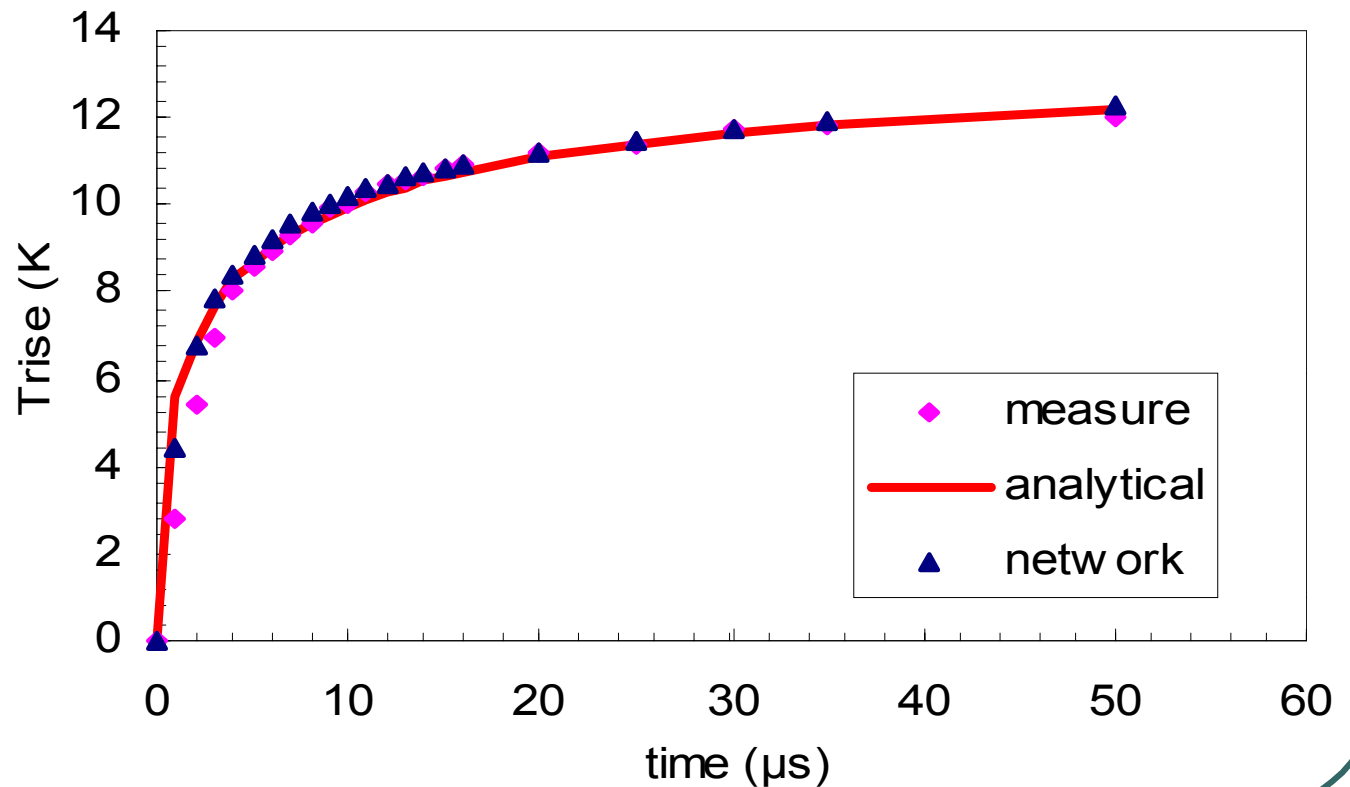
- $\lambda = 148 \text{ W/mK}$
- $C = 710 \text{ J/kgK}$
- $\rho = 2330 \text{ kg/m}^3$
- $n = 10$



Comparison

- Transient response

- $\lambda = 148 \text{ W/mK}$
- $C = 710 \text{ J/kgK}$
- $\rho = 2330 \text{ kg/m}^3$
- $n = 10$



Conclusion

- Development of a temperature dependant dynamic compact model
 - Resolution of heat transfer differential equation
- Equivalent network representation for the SPICE compatibility
 - Linear network
 - Recursive network
 - Improved recursive network
 - Recursive representation is a good approximation for thermal impedance
 - Only three parameters to be extracted
- Tested on advanced technology